Column 1	Column 2	Column 3	Column 4	Column 5
Tariff Item Number	Description of Goods	Base Rate	Category	Note
8486.20.94.00.00	- - - Inductance or dielectric furnaces and ovens for the manufacture of semiconductor devices on semiconductor wafers		A	
8486.20.95.00.00	- - - Automated machines for the placement or the removal of components or contact elements on semiconductor materials		A	
8486.20.99.00.00	- - - Other		A	
8486.30	- Machines and apparatus for the manufacture of flat panel displays:			
8486.30.10.00.00	- - Apparatus for dry etching patterns on flat panel display substrates		A	
8486.30.20.00.00	- - Apparatus for wet etching, developing, stripping or cleaning flat panel displays		A	
8486.30.30.00.00	- - Chemical vapor deposition apparatus for flat panel display production; spinners for coating photosensitive emulsions on flat panel display substrates; apparatus for physical deposition on flat panel display substrates		A	
8486.30.90.00.00	- - Other		A	
8486.40	- Machines and apparatus specified in Note 9 (C) to this Chapter:			
8486.40.10.00.00	- - Focused ion beam milling machines to produce or repair masks and reticles for patterns on semiconductor devices		A	
8486.40.20.00.00	- - Die attach apparatus, tape automated bonders, wire bonders and encapsulation equipment for the assembly of semiconductors; automated machines for transport, handling and storage of semiconductor wafers, wafer cassettes, wafer boxes and other materials for semiconductor devices		A	
8486.40.30.00.00	- - Molds for manufacture of semiconductor devices		A	
8486.40.40.00.00	- - Optical stereoscopic microscopes fitted with equipment specifically designed for the handling and transport of semiconductor wafers or reticles		A	
8486.40.50.00.00	- - Photomicrographic microscopes fitted with equipment specifically designed for the handling and transport of semiconductor wafers or reticles		A	
8486.40.60.00.00	- - Electron beam microscopes fitted with equipment specifically designed for the handling and transport of semiconductor wafers or reticles		A	
8486.40.70.00.00	- - Pattern generating apparatus of a kind used for producing masks or reticles from photoresist coated substrates	5%	B2	
8486.40.90.00.00	- - Other		A	
8486.90	- Parts and accessories:			
	- - Of machines and apparatus for the manufacture of boules or wafers:			
8486.90.11.00.00	- - - Of apparatus for rapid heating of semiconductor wafers		A	
8486.90.12.00.00	- - - Of spin dryers for semiconductor wafer processing		A	
8486.90.13.00.00	- - - Of machines for working any material by removal of material, by laser or other light or photon beam in the production of semiconductor wafers		A	
	- - - Of machines for sawing monocrystal semiconductor boules into slices, or wafers into chips:			
8486.90.14.00.00	- - - - Tool holders and self-opening dieheads; work holders; dividing heads and other special attachments for machine tools		A	
8486.90.15.00.00	- - - - Other		A	
8486.90.16.00.00	- - - Of grinding, polishing and lapping machines for processing of semiconductor wafers		A	
8486.90.17.00.00	- - - Of apparatus for growing or pulling monocrystal semiconductor boules		A	
8486.90.19.00.00	- - - Other		A	
	- - Of machines and apparatus for the manufacture of semiconductor devices or of electronic integrated circuits:			
8486.90.21.00.00	- - - Of chemical vapor deposition apparatus for semiconductor production		A	
8486.90.22.00.00	- - - Of epitaxial deposition machines for semiconductor wafers; of spinners for coating photographic emulsions on semiconductor wafers		A	
8486.90.23.00.00	- - - Of ion implanters for doping semiconductor materials; of apparatus for physical deposition by sputtering on semiconductor wafers; of physical deposition apparatus for semiconductor production; of direct write-on-wafer apparatus, step and repeat aligners and other lithography equipment		A	